

Search Notes



Application/Control No.

10/528,306

Examiner

Tae W. Kim

**Applicant(s)/Patent under
Reexamination**

THEVENOT, BENOIT

Art Unit

2876

SEARCHED

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	DATE	EXMR
Text Search	10/1/2006	KIM
EAST	10/1/2006	KIM
Partial Class Search: 235/492, 156/272.8, 438/106, 438/107, 257/678	10/1/2006	KIM
Consulted Jared Fureman @ AU2876	10/27/2006	KIM
Referenced Search Report for PCT/IB03/04011	3/21/2007	KIM
Consulted Jared Fureman @ AU2876	3/21/2007	KIM
Consulted Steve Paik @ AU2876	3/21/2007	KIM
Search Updated	3/21/2007	KIM

Search Notes (continued)



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